



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3756**

Tomohiro OKUMURA et al. : Docket No. 00177/530809

Serial No. 09/511,398 : Group Art Unit 1762

Filed February 23, 2000 : Examiner M. Padgett

PLASMA PROCESSING METHOD  
AND APPARATUS :

**PETITION FOR EXTENSION OF TIME**

Assistant Commissioner for Patents,  
Washington, DC 20231

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of  
September 20, 2002.

The fee of \$930.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is  
enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion  
which

() is enclosed.

() has been previously submitted.

03/21/2003 MDANTE1 00000124 09511398

02 FC:1253

930.00 DP

Respectfully submitted,

Tomohiro OKUMURA et al

By

W. Douglas Hahn

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March 20, 2003

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